



LHC Injectors Upgrade

# LIU beam performance ramping up: SPS ions

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# Introduction

- HL-LHC requirement to double the peak luminosity at the Pb-ion run after LS2
  - Increase the number of bunches in the LHC
- LIU baseline to achieve that is by performing slip-stacking (slip-interleaving) in the SPS
  - Two beams of different momenta slip azimuthally, relative to each other, in the same beam pipe.
  - The beams can be then interleaved reducing the bunch spacing by half and thus doubling the number of bunches





## Slip-stacking procedure in SPS

- Two SPS batches of 24 bunches spaced by 100 ns are going to be interleaved at a constant energy plateau
  - Resulting to a single batch of 48 bunches with 50 ns bunch spacing

- The two batches are controlled by two independent
  RF systems with small frequency difference between them (within the bandwidth of the main 200 MHz RF system)
- II.-III. The batches slip towards each other, following the designed RF programs (frequency, voltage).
- IV. When the two beams are in correct position the full beam is recaptured with a much higher RF voltage at the average RF frequency.





#### Energy plateau selection

- Flat bottom: relatively strong transverse space charge and intra-beam scattering effects, simplified scaling laws show that all the relevant to slip-stacking parameters favour higher energies.
- Flat top: bunches more prone to longitudinal instabilities, un-captured beam generated during the process, would be transferred to the LHC
- Slip-stacking at intermediate energy plateau at 300 ZGeV/c → around 1 s needs to be added to the cycle.

- ✓ Well above  $γ_{tr}$  → favourable for slip-stacking.
- ✓ No intra-beam scattering and space-charge issues as in the long (~40 s) injection plateau.
- ✓ Better longitudinal beam stability compared to flat-top.
- Uncaptured beam will not be transferred to the LHC.





#### • RF perturbation

- The group of cavities that is not synchronised with the batch will perturb its motion.
- The perturbation is described by the slip-stacking parameter

$$\alpha \stackrel{\text{\tiny def}}{=} \frac{\Delta f_{RF}}{f_{s0}} = 2 \frac{\Delta E}{H_B}$$

 $\Delta f_{RF}$ : difference in RF frequency  $f_{s0}$ : zero amplitude synchrotron frequency  $\Delta E$ : Energy difference  $H_B$ : half bucket height

 $\alpha$  =4 lowest stability limit  $\rightarrow$  for  $\alpha \leq 4$  motion becomes chaotic!!

#### Two implications during slip-stacking

- Start: α =0 → RF amplitude modulation necessary to separate the batches (one group should be active when the corresponding batch passes by) → minimum acceptable initial distance between the batches based on the cavities filling time.
- End: beams should remain separated in energy at the moment of recapture → high RF voltage is needed at the end to capture all

The particles of the separated beams  $\rightarrow$  large emittance blow-up.



#### • RF program calculations

- At the start of slip-stacking the RF cavities will split into two groups and each group will be synchronized with one of the two batches
- Each group should follow different RF frequency (momentum) and voltage and programs





#### RF program calculations

- At the start of slip-stacking the RF cavities will split into two groups and each group will be synchronized with one of the two batches
- Each group should follow different RF frequency (momentum) and voltage and programs.
- These programs are calculated assuming constant longitudinal emittance  $\varepsilon_l$  and filling factor in energy  $q_E$  and also treating independently the two RF systems
- In the future they will be calculated through a high level application and will be given as an input to the hardware.
  - Calculation of programs using required machine and beam parameters
  - ✓ Send values to the hardware
  - ✓ Very fast to run (less than a minute)
  - Easy to change parameters and recalculate during the beam set-up





- Beam parameters
  - Significant bunch to bunch variation in intensity and emittance along the batch generated during the long injection plateau (~40 s).
  - Voltage programs calculated for the largest bunch to avoid losses during slip-stacking.
  - The RF noise reduction is expected with the new LLRF which will decrease the blow-up of the beam and thus will reduce the spread



#### • Independent LLRF controls for each group of RF cavities after LS2

- Design of the slip-stacking process was based on realistic macro-particle simulations using the BLonD code, including
  - Measured beam parameters (longitudinal bunch distribution, emittance, intensity).
  - The detailed longitudinal impedance model.

#### • Large number of simulations to optimize the process

- Both for Q20 and Q26 optics.
- Simulations of the full beam started at 300 ZGeV/c taking into account the measured beam parameters at this moment of the cycle.
- Scanning parameters:  $\alpha$ ,  $q_e$ ,  $V_{rf}$
- Minimization of:
  - Total losses *L*<sub>tot</sub>
  - $^{\scriptscriptstyle -}$  Long. emittance  $\varepsilon_l$  (fit the LHC 400 MHz RF bucket)
- At flat top ( $V_{rf} = 15MV$ ):
  - Adiabatic bunch compression
  - Bunch rotation





- No acceptable solution (in bunch length) for Q20 optics with adiabatic bunch rotation
  - bunch rotation is needed in order to achieve sufficiently short bunches at extraction
- Q26 optics was selected for slip-stacking
  - provides more margin to the final beam parameters.





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#### Hollow bunch generation after momentum slip-stacking

- At the end of slip-stacking manipulation  $\alpha >$ 4 to avoid losses.
- Bunches strongly un matched to the RF bucket at the moment of recapture.





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#### Hollow bunch generation after momentum slip-stacking

- At the end of slip-stacking manipulation  $\alpha >$ 4 to avoid losses.
- Bunches strongly un matched to the RF bucket at the moment of recapture.
- After filamentation a hollow bunch will be generated in the longitudinal phase space
- This distribution is preserved until the end of the cycle





• Loss of Landau damping is observed for the shortest bunches in the batch when intensity effects are included in simulations

• Dipole oscillations are not damped until the end of the cycle





- Loss of Landau damping is observed for the shortest bunches in the batch when intensity effects are included in simulations
  - Dipole oscillations are not damped until the end of the cycle
  - High density island in phase-space that keeps oscillating around the bucket centre





- Obvious solution to increase the Loss of Landau damping threshold is to use the 800 MHz RF system
  - Effectively no damping when 800 MHz is switched on only at flat top



#### • Obvious solution to increase the Loss of Landau damping threshold is to use the 800 MHz RF system

- Effectively no damping when 800 MHz is switched on only at flat top
- We need to use it immediately at recapture and keep it on for the rest of the cycle



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BSM

BLM



### Longitudinal beam stability of ion beams

- Series of relevant to slip-stacking measurements was carried out in end of 2018
  - Check longitudinal beam quality
- A new slip-stacking short MD cycle with the addition of 1 s energy plateau at 300 ZGeV/c.



# Beam measurements in 2018

Beam stability and reproducibility key component for a successful implementation of slip-stacking.

- Beam instabilities after transition crossing observed in measurements
- Stabilised by a deliberate degradation transition crossing
  - Strong longitudinal emittance blow-up

Optimisation of transition crossing shifted instabilities later in the cycle



#### Beam measurements in 2018



 □ Enhances bunch-by-bunch variation in the batch
 □ Uncontrolled blow-up → non reproducibility from cycle to cycle



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Important to stabilise the beam before slip-stacking can be applied

#### **Macro-particle simulations**



#### **Macro-particle simulations**





Time [s]

#### **After LS2 impedance reduction**



Slightly smaller beam perturbation after transition crossing is expected from simulations in the future, after the SPS impedance reduction

Bunch is still quite unstable even at low energy (1.8x10<sup>10</sup> protons/b).

□ Bunch parameters are still strongly depended on any jitter during the phase-jump at transition crossing → non reproducible beam parameters at extraction

# **Double RF operation**









#### **Beam commissioning**

#### • One week is preliminary reserved in September 2021 for the slip-stacking commissioning

- SPS ions FFA will be commissioned at the beginning of the summer.
- Possibility to check the slip-stacking hardware already in summer (RF programs generation, grouping and controlling independently the RF cavities, etc.), even without beam.
- Possibility to check the slip-stacking manipulation with proton pilot bunches in MDs (requires generation of new MD cycle)
- Everything depends on the availability of the LLRF experts and how the setting up of the proton beams is evolving.





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#### **Beam commissioning steps**

- Commissioning the high level tools for generating the frequency and voltage programs and sending them to hardware
  - Could be checked earlier without beam
- Commissioning with a short magnetic cycle
  - Only up to two injections needed. Very similar to the one used in 2018 MDs
- Start with one bunch to check and improve the longitudinal beam quality through the cycle
  - Reproducible bunch parameters in terms of emittances at the slip-stacking plateau
  - Use of the 800 MHz RF system will be needed after FFA. Will be hopefully checked earlier in summer during the SPS ions cycle setting up.
- One (or two) bunches to check the slip-stacking procedure and final beam parameters
  - RF voltage amplitude modulation
  - Beam emittance and losses at extraction
  - Optimise the designed RF programs during slip-stacking and also later when ramping up to top energy (capture voltage, bucket filling factor etc.)
  - Need of quick macro-particle simulations at the same time

#### Increase the number of batches gradually

- Long, nominal cycle is needed  $\rightarrow$  dedicated supercycle
- Adapt the designed RF programs for the new beam parameters.



### **Summary and conclusions**

#### • Man power during the week of setting up slip-stacking

- It's possible that we need to work also during nights
- Simulations might be needed at the same time to understand and overcome potential difficalties





# **RF perturbation during slip-stacking**



 $\alpha = 0$  in the beginning  $\rightarrow$  RF amplitude modulation is necessary to separate the batches  $\rightarrow$  minimum  $d_b$  ( $T_B$  in time) based on the filling time of the cavity

□ High RF voltage is needed at recapture → a large emittance blow-up.

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#### Macro-particle simulations $\rightarrow$ reproduce the data

